

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/643,974	MEI ET AL.	
Examiner	Art Unit	
CYNTHIA LEE	1795	

SEARCHED					
Class	Subclass	Date	Examiner		

INTERFERENCE SEARCHED					
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
updated EAST search	12/4/2009	CL		